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| FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE | | ATTY. DOCKET NO. ARC920010017US1 | SERIAL NO. Not assigned |
| LIST OF PRIOR ART CITED BY APPLICANT (Use several sheets if necessary) | | APPLICANT Robert Edward Fontana Jr. et al. #2 | |
| | | FILING DATE Not assigned | GROUP Not assigned |

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05/10/01

U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
|---------------------|---|--------------------|--------|----------------|-------|----------|----------------------------------|
| JA | A | 5 0 7 9 0 3 5 | 1/7/92 | Krounbi et al. | 427 | 130 | 12/18/90 |
| | B | | | | | | |
| | C | | | | | | |
| | D | | | | | | |
| | E | | | | | | |
| | F | | | | | | |
| | G | | | | | | |
| | H | | | | | | |

FOREIGN PATENT DOCUMENTS

| | | DOCUMENT NUMBER | ISSUE DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION | |
|--|---|--------------------|---------------|---------|-------|----------|-------------|----|
| | | | | | | | YES | NO |
| | I | | | | | | | |
| | J | | | | | | | |
| | K | | | | | | | |

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

| | | |
|----|---|---|
| JA | L | G. J. Dolan; "Offset masks for lift-off photoprocessing;" Applied Physics Letters, Vol. 31, No. 5, 1 September 1977 |
| | | |
| | M | |
| | | |
| | N | |
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| EXAMINER John McPherson | DATE CONSIDERED 7/15/03 |
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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.